Substitute for form PTO-1449

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INFORMATION DISCUSIVE STATEMENT BY APPLICANT

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Application Number	ssigned U 1 5 1 U 3 5 1.
Filing Date	October 5, 2004
First Named Inventor	Jing Hua Teng
Group Art Unit	
Examiner Name	
Attorney Docket	3136.ARTH.PT

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STATEMENT BY APPLICANT	Filing Date
OIPE	First Named Inventor
(use as many sheets as necessary)	Group Art Unit
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Complete if Known				
Application Number 10/510,357				
Filing Date	October 5, 2004			
First Named Inventor	Jin Hua Teng et al.			
Group Art Unit	2812			
Examiner Name				
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Substitute for form PTO-1449			. Co	mplete if Known
, INFO	RMATION DIS	CLOSUBE	Application Number	10/510,357
STAT	TEMENT BY AP	PLICANT	Filing Date	October 5, 2004
		Zine c un.	First Named Inventor	Jin Hua Teng et al.
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			Examiner Name	
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